## Notice of References Cited Application/Control No. 10/008,731 Examiner Ann Loftus Applicant(s)/Patent Under Reexamination LIU ET AL. Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-6,836,773	12-2004	Tamayo et al.	707/6
	В	US-			
	С	US-			
	D	US-			
	Е	US-			
	F	US-			
	G	US-			
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	J	US-			
	·K	US-			
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## FOREIGN PATENT DOCUMENTS

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## **NON-PATENT DOCUMENTS**

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